

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|  |   |
|--|---|
| In re application of: Shen et al.  | Group Art Unit: 1746                          |
| Application No: 09/507,629   | Examiner: Allan W. Olsen                      |
| Confirmation No: 7912  | Attorney Docket No:                           |
| Filed: February 18, 2000   | 001945 USA P03/ETCH/SILICON/JB                |
| Title: SELF-CLEANING PROCESS FOR<br>ETCHING SILICON-CONTAINING<br>MATERIAL | January 23, 2003<br>San Francisco, California |

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

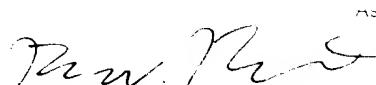
Box Non-Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Examiner Olsen:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of the form be returned to the undersigned.

Under 37 C.F.R 1.97(c), an Information Disclosure Statement shall be considered by the Office if filed before the mailing date of the final action or notice of allowance, provided it is accompanied by a certification as specified in Paragraph (e) or a petition fee.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to:

By   
Reece Nienstadt

Assistant Commissioner for Patents  
Washington D C 20231

Date January 23, 2003

Please charge Deposit Account No. 10-0258 in the amount of \$180.00 for payment of the associated petition fee.

The Commissioner is hereby authorized to charge payment of any additional fees associated with this communication and credit any overpayment to Deposit Account No. 10-0258.

It is believed that this disclosure complies with the requirements of 37 C.F.R. §§ 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures § 707.05(b). If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations provided herewith, the undersigned does not know how the translations were made, nor who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

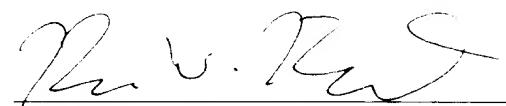
These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES  
A PROFESSIONAL CORPORATION

Dated: January 23, 2003

By

  
Reece Nienstadt  
Reg. No. 52,072

Please direct all telephone calls to:

Reece Nienstadt  
(415) 538-1555

Please continue to send correspondence to:

Applied Materials, Inc.  
Patent Department M/S 2061  
P. O. Box 450A  
Santa Clara, California 95052

Encl.